



C | T 532

GLAUCOMA

THERAPY

FOR

**MAXIMUM** 

**DEMANDS** 

LASER...INNOVATION
MADE IN GERMANY

CITO 532 A.R.C.

www.arclaser.de info@arclaser.de

Modern Laser architecture - quick refresh

Microchip Technology CITO 532





Designed for the anterior segment

Highest repetition rate

Homogeneous spot quality

Highest pulse-to pulse stability: unique in OPHTHALMOLOGIE

Secure compartment for all cable-onnections Anti collission system for tall patients

Electronic Niveauadjustment up to 920 mm with 2 height adjustable lifts

Stable and slim design, wheelchair accessible

# Spacious legroom

920 mm

260 333

The compact system combines laser, able and slit lamp - wheels are available on request.

692 mm

# THE MODERN SLT

Homogeneous spot quality for optimal reproducibility

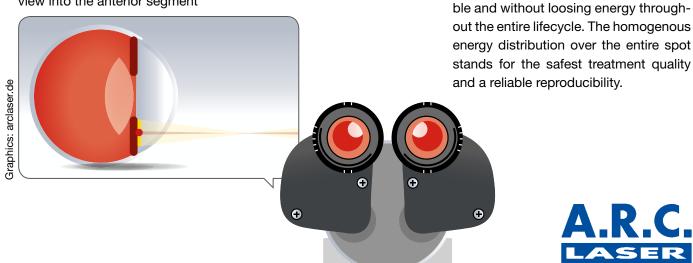






#### Slit lamp PCL5 Z

Specially coated optics with parallel or convergent tube provide a detailed view into the anterior segment



No heating on the housing and no UV

light at the cavity. The life time of the

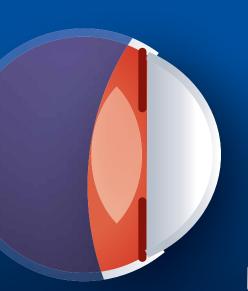
CITO 532 is theoretically unlimited - sta-

### The perfect optic for the anterior eye segment



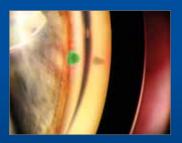
## PCL5 Z

Designed for the anterior segment





CITO 532 SLT Laser





THE SLT LASER TREATMENT STIMULATES THE TRABECULAR MESHWORK IN A SPECIFIC WAY AND GENERATES A SIGNIFICANT REDUCTION OF INTRAOCULAR PRESSURE (IOP) IN A NATURAL WAY







The laser beam activates the trabecular meshwork. The ideal treatment is done with an angle of 180° per session.

### The most homogeneous spot in A.R.C. Laser history

Regards to the quality of our laser spot - the CITO GEN-II beam stands out in terms of reliability and stability compared to the predecessor TRABECULAS.

Thanks to the microchip architecture with its quick refresh and stable laser specifications - you and your patients could benefit from a better reproducibility and predictability of the procedure.





### **MORE OPTIONS: VARIO.**

2 high-class lasers on one table.

#### **TECHNICAL SPECIFICATIONS**

**SLT-LASER CITO 532 GEN II** 

laser	Q-switched 532 nm microchip triggered frequency doubled Nd:YAG
energy	0,2 to 2,0 mJ continuous
spot diameter	400 µm in aiming beam focus
repetition rate, pulse	>10 Hz
pulse width	3 ns
aiming beam	635 nm / 1 mW, variable
treatment angle	3,2°
arrangement of laser source	central with the microscope
space needed	0,5 m <sup>2</sup> table: 86 cm x 46 cm
power requirements	100 bis 240 V 47/63 Hz, 5 A
laser class aiming beam:	<b>3b</b>   532 nm, E = 2,5 mJ <b>2</b>   635 nm, P < 1 mW

Alterations of the described features or pictured features are possible. Please keep updated on the current status before ordering.

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VISIBLE AND INVISIBLE LASER RADIATION
Avoid direct irradiation of eye or skin or scattered radiation.
laser class: see technical specifications



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